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10/690,177



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Patent Application of

Chuong Vu

Application No. 10/690,177

Filed: **October 20, 2003**

For: Joining Material Stencil and  
Method of Use

Group Art Unit: 2822

Examiner: Guerrero, Maria F.

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action including a Restriction Requirement mailed on  
February 25, 2005, please consider the following.